



SDI Review Form 1.6

Journal Name:	Journal of Materials Science Research and Reviews
Manuscript Number:	Ms_JMSRR_46490
Title of the Manuscript:	Preparation and Physical Properties of CuxZn1-xS thin films Deposited by Metal Organic Chemical Vapour Deposition Technique.
Type of the Article	Original Research Article

General guideline for Peer Review process:

This journal's peer review policy states that **NO** manuscript should be rejected only on the basis of '**lack of Novelty**', provided the manuscript is scientifically robust and technically sound. To know the complete guideline for Peer Review process, reviewers are requested to visit this link:

(<http://www.sciencedomain.org/page.php?id=sdi-general-editorial-policy#Peer-Review-Guideline>)

PART 1: Review Comments

	Reviewer's comment	Author's comment (if agreed with reviewer, correct the manuscript and highlight that part in the manuscript. It is mandatory that authors should write his/her
Compulsory REVISION comments		
Minor REVISION comments		
Optional/General comments	This manuscript focused on the Physical Properties of CuxZn1-xS thin films. However, this article is similar to the technical report, which is not very interesting and no novel study. Especially, the introduction is needed to describe the application and how to improve the quality of all figures. However, some parts need to revise, which are listed below as follows. [1] The frame of Figure 5 is not all framed. Moreover, the resolution of Figures 1 and 2 is not clear. Please revise them.	Thanks, for your thorough review. We have worked on the figures mentioned.

PART 2:

	Reviewer's comment	Author's comment (if agreed with reviewer, correct the manuscript and highlight that part in the manuscript. It is mandatory that authors should write his/her feedback here)
Are there ethical issues in this manuscript?	(If yes, Kindly please write down the ethical issues here in details)	NO